

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re application of | : | Confirmation No. 1821 |
| Mitsuhiro OKUNE et al, | : | Attorney Docket No. 2006_0772A |
| Serial No. 10/581,256 | : | Group Art Unit 1792 |
| Filed May 31, 2006 | : | Examiner Mahmoud Dahimene |
| PLASMA ETCHING METHOD | : | Mail Stop AMENDMENT |

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed May 15, 2009, please amend the above-identified application as follows.